

**METHOD, SYSTEM AND FACILITY FOR MONITORING RESOURCES
WITHIN A MANUFACTURING ENVIRONMENT**

ABSTRACT OF THE DISCLOSURE

A method, system and logic are described for
monitoring resources within a manufacturing environment.
A system for monitoring resources within a manufacturing
facility includes a remote monitoring system coupled to
one or more pieces of equipment within the manufacturing
facility. The remote monitoring system may be
communicatively coupled to a control center operable to
display status information associated with using the one
or more pieces of equipment.